

Notice of References Cited	Application/Control No. 10/716,552	Applicant(s)/Patent Under Reexamination KARIN, JACOB	
	Examiner Arnel C. Lavarias	Art Unit 2872	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,801,880	09-1998	Matsuda et al.	359/385
	B	US-6,639,201	10-2003	Almogoy et al.	250/208.1
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 07181023 A	07-1995	Japan	WAKAI et al.	G01B011/24
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	U.S. Application No. 10/230,207 to Karin et al., filed August, 2002.
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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